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4. Application number(s) or patent numb	er(s):				
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A. Patent Application No.(s) 09/338,071		B. Patent No.(s)			
Additional numbers attached? Yes No					
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concerning document should be maile Name: Robin Clay Fritsch	u.	7. Total fee (37 CFR 3.41)\$ 0.00			
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LICENSE TO THE UNITED STATES GOVERNMENT

WHEREAS, George Cragg et al have invented "Standing Wave Total Internal Reflection Microscopy" and filed a patent application thereon in the United States, entitled "Standing Wave Total Internal Reflection Imaging" and bearing Serial Number 09/338,071 and filing date June 23, 1999; and

WHEREAS, invention was made in the course of research supported by the National Science Foundation under N.S.F. Grant No. MCB9604382; and

WHEREAS, the United States Government is entitled to certain rights in and to said invention and application by reason of the terms relating to such support; and

WHEREAS, the Massachusetts Institute of Technology, hereinafter called the "Licensor" has acquired by assignment from the inventors the entire right, title and interest of the inventors to such invention:

NOW, THEREFORE:

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Signed this _____ day of February, 2000 .

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Patent Administrator/Office Manager

Accepted for the benefit of the Government this

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